

(19)



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(11)

**EP 0 763 192 B1**

(12)

**EUROPEAN PATENT SPECIFICATION**

(45) Date of publication and mention  
of the grant of the patent:  
**26.07.2000 Bulletin 2000/30**

(51) Int Cl.7: **G01H 9/00**

(86) International application number:  
**PCT/US96/04026**

(21) Application number: **96910541.0**

(87) International publication number:  
**WO 96/30731 (03.10.1996 Gazette 1996/44)**

(22) Date of filing: **25.03.1996**

**(54) ULTRASONIC DETECTOR USING VERTICAL CAVITY SURFACE EMITTING LASERS**

ULTRASCHALLDETEKTOR MIT OBERFLÄCHENEMITTIERENDEN LASERN MIT VERTIKALEN  
RESONATOREN

DETECTEUR ULTRASONIQUE UTILISANT DES LASERS EMETTANT PAR LA SURFACE D'UNE  
CAVITE VERTICALE

(84) Designated Contracting States:  
**DE FR IT**

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(30) Priority: **31.03.1995 US 414833**

(43) Date of publication of application:  
**19.03.1997 Bulletin 1997/12**

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**US-A- 4 546 458**                      **US-A- 5 331 658**  
**US-A- 5 367 496**

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• **IEEE JOURNAL OF QUANTUM ELECTRONICS,**  
**vol. 27, no. 6, 1 June 1991, pages 1332-1346,**  
**XP000229828 JEWELL J L ET AL:**  
**"VERTICAL-CAVITY SURFACE-EMITTING**  
**LASERS: DESIGN, GROWTH, FABRICATION,**  
**CHARACTERIZATION" cited in the application**

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## Description

### Background of the Invention

[0001] This application is related to commonly assigned U.S. Pat. Application Serial No. \_\_\_\_\_, (RD-24,321) filed \_\_\_\_\_, 1995, of AR Duggal et al., filed concurrently herewith.

[0002] This invention relates generally to imaging of acoustic energy, more particularly to laser-based ultrasound detection equipment and most particularly to an array of semiconductor microlaser-based ultrasound detection equipment.

[0003] Ultrasound equipment is commonly used in medical imaging and for non-destructive evaluation (NDE) of materials. Ultrasound analysis involves the propagation of energy through solids, liquids, and gases as acoustic waves; typically a pulse of acoustic energy is applied to an object to be imaged and reflected waves of the acoustic pulse are detected and processed for imaging and analysis. The spatial relationship and amplitude of the reflected waves provide information as to the location and nature of structures that reflected the acoustic energy in the object being analyzed.

[0004] Piezoelectric transducers are frequently used to generate ultrasound pulses transmitted into the object to be analyzed and to detect reflected waves received at the transducer. Piezoelectric devices require extensive electrical cabling which places practical limits on the number of pixels that can be placed in a transducer array, which in turn limits the resolution of the array.

[0005] Specifically, when utilizing piezoelectric transducers for ultrasound equipment used in medical imaging, currently a one-dimensional array of 128 elements or pixels are utilized. The piezoelectric pixels are each independently electrically connected by wires to the signal processing unit which would then process the signals received from the transducers to an imaging. In order to improve the ultrasound image quality, it is desired that a two-dimensional array with, such as, for example, 128 x 128 transducers/pixels is needed. Due to the complexity of the many wires required to connect the piezoelectric transducers to the signal processor, and the complexity thereof, to utilize piezoelectric transducers is simply too complex.

[0006] Optical techniques have also been used for generation and detection of acoustic waves in ultrasound imaging. For example, energy from a laser beam focused on the surface of an object to be examined can generate an acoustic pulse in the object. The return pulse of acoustic energy is typically detected optically through the use of interferometry. A review of such techniques is provided in the book Laser Ultrasonics - Techniques and Applications by C.B. Scruby and L.E. Drain (IOP Publishing Ltd 1990). Noninterferometric techniques of optical detection of ultrasound include the knife-edge and surface-grating techniques and techniques based on reflectivity and light filters. See "Optical

Detection of Ultrasound" by J.P. Monchalín, IEEE Transactions on Ultrasonics, Ferroelectrics, and Frequency Control, UFFC-33, September 1986. These laser-based methods of ultrasound detection are much less sensitive, by several orders of magnitude, than conventional piezoelectric-based methods.

[0007] Another laser-based method for detecting sound waves has been suggested in the article "Laser Hydrophone" by Y.A. Bykovskii et al., in Sov. Phys. Acoust. 34, p 204, March 1988. In the Bykovskii et al. optical hydrophone, movement of the hydrophone membrane varies the power and/or the phase of a semiconductor laser in the hydrophone to generate changes in the amplitude of an optical signal. The Bykovskii sonar hydrophone is relatively inefficient and thus has low sensitivity.

[0008] In a more recent approach to the use of an optical transducer assembly for ultrasound applications, an optical transducer assembly which includes a transducer housing and a signal laser, such as a microcavity laser or a microchip laser that is optically pumped, to detect ultrasound by monitoring the frequency modulation of the laser output caused by the interaction of the ultrasonic disturbance with the laser cavity, was mounted in the transducer housing. This interaction could involve a change in the laser cavity length and/or a change in the index of refraction of the lasing medium. This approach further detailed a scheme using fiber optic cables to reduce the interconnect complexity when using an array of microcavity lasers. The optical frequency generated by the signal laser is modulable (that is, adapted to or capable of being modulated) in correspondence with acoustic energy incident on the transducer assembly. The signal laser comprises an optical cavity in which a lasing medium is disposed, and first and second reflectors that are disposed at respective opposite end surfaces of the optical cavity along an optical path axis of the cavity. The second reflector can alternatively be replaced with a compliant cavity that acts as a Gires-Toumois interferometer. The signal laser is adapted such that acoustic energy incident on the transducer assembly changes the length of a cavity along the optical path axis, or, alternatively, changes the index of refraction in the optical cavity, and such changes result in a substantially linear variation of the optical frequency of light generated by the laser.

[0009] In one embodiment, as disclosed in US Patent No. 5,353,262, assigned to the assignee of the present application, an optical transducer, such as used in an ultrasound system, includes a signal laser which generates an optical signal the frequency of which varies in correspondence with acoustic energy incident on the transducer. An optical cavity in the signal laser is disposed such that incident acoustic energy causes compression and rarefaction of the optical cavity, and this displacement varies optical frequency generated by the laser. A laser pump coupled to the lasing medium is adapted to apply selected levels of excitation energy ap-

appropriate to the detection of acoustic pulses. The signal laser alternatively is adapted such that the refractive index of the optical cavity is varied in correspondence with the incident acoustic energy to modulate the optical frequency of the light generated by the signal laser.

[0010] In an alternate embodiment, a piezoelectric device is disposed to receive the incident acoustic energy and generate a corresponding electrical signal that is applied to an electro-optic cell in the optical cavity, or alternatively, to conductors to generate an electric field across the lasing medium.

[0011] Despite the efforts described above to provide a simpler, more compact ultrasound detection device, a need still exists in medical imaging and nondestructive evaluation (NDE) of materials for an ultrasound transducer interfaced to support equipment which minimizes interconnection complexity. For example, as stated above, current state-of-the-art ultrasound imaging arrays use a linear array of about one hundred separate ultrasound pixels each of which are connected to a separate coaxial cable. Array sizes are currently limited by the complexity of the interconnect cabling. By using an optical interface between the transducer head and support equipment, cabling can be significantly reduced in size for the same number of pixels. Alternatively, a much larger number of pixels can be connected by the same size cable. Additionally, it would be advantageous for NDE and underwater acoustic sensing applications to be able to detect as wide a frequency bandwidth of acoustic signals as possible. Finally, ultrasonic microscopic imaging of biological and micro-electronic structures requires an array of small, high bandwidth ultrasonic detectors in contact with the sample being imaged.

### **Summary of the Invention**

[0012] The ultrasound/vibration detector array of the present invention comprises an electrically pumped vertical cavity surface emitting laser (VCSEL) array. The cavity length of each laser or pixel of the array is modulated by the acoustic field at the point where the acoustic field contacts the pixels. The resulting laser output is frequency modulated by the acoustic field. This modulation is converted to amplitude modulation at the detector head and then either detected with a charge-coupled-device (CCD) array with the information being electrically communicated to the signal processing assembly or sent directly by optical fiber to the signal processing assembly for processing. The ultrasound/vibration detector array of the present invention provides high frequency bandwidth detection, fine spatial resolution, and minimal electric cabling.

[0013] One embodiment of the present invention includes, a detector for detecting acoustic energy propagated through a medium, the detector comprising: a detector housing, and an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively po-

sitioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field.

[0014] Another embodiment of the present invention includes, an ultrasonic microscope comprising: an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively positioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field; an acoustic matching layer operatively positioned between the electrically pumped vertical cavity surface emitting laser (VCSEL) array and a sample to be imaged; a transparent acoustic backing layer operatively connected to the VCSEL array, the VCSEL array generating an array of optical beams whose optical frequencies are modulated by the incident ultrasonic field, the beams being propagated through free space or Fiber-optic cabling; and a Fabry-Perot cavity array, operatively positioned relative to the backing layer but separated therefrom by free space or Fiber-optic cabling, for converting the frequency modulation of the laser output caused by the acoustic disturbance into amplitude modulation.

[0015] A still further embodiment of the present invention includes, an ultrasound system for analyzing a subject, comprising: a detector, and a signal processing assembly operatively connected to the detector, the optical detector comprising: a detector housing, and an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively positioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field.

[0016] It is accordingly an object of the present invention to provide a laser detector for detecting acoustic energy.

[0017] It is a further object of the present invention to provide a laser ultrasound system that is relatively compact.

[0018] It is another object of the present invention to provide a laser ultrasound detector having a large number of detector pixels in a compact detector array.

[0019] A still further object of the present invention is to provide a laser ultrasound detector that exhibits high sensitivity and a wide dynamic range.

[0020] Other objects and advantages of the invention will be apparent from the following description, the accompanying drawings and the appended claims.

### **Brief Description of the Drawings**

[0021]

Figure 1 is a block diagram of an ultrasound system comprising the present invention;

Figure 2 is a schematic diagram of an optical detector illustrating one embodiment of the present invention;

Figure 3 is a schematic diagram of an optical detector illustrating another embodiment of the present invention; and

Figure 4 is a schematic diagram of an optical detector illustrating yet a further embodiment of the present invention.

### **Detailed Description of the Invention**

[0022] Figure 1 illustrates an ultrasound system 10 for analyzing an examination object 15 with acoustic energy comprising a detector 20, a signal processing assembly 30, and a display and analysis module 40. Detector 20 is acoustically coupled to object 15 through an acoustic couplant or matching layer 25 such that acoustic energy reflected from or transmitted through object 15 is received by detector 20.

[0023] In accordance with the present invention, detector 20 is adapted so that acoustic energy incident on the detector modulates the cavity length of each pixel of the electrically pumped vertical cavity surface emitting laser (VCSEL) array. This modulation is converted to optical frequency modulation of each pixel of the electrically pumped VCSEL which is in turn converted to optical amplitude modulation for each pixel. Detector 20 is in turn operatively connected to signal processing assembly 30 such that a processed output signal corresponding to the received acoustic energy is generated. Display and analysis module 40 is operatively connected to processing assembly 30 so that the processed output signal is visually presented or otherwise analyzed.

[0024] The present invention utilizes an array of vertical cavity surface emitting lasers (VCSEL's) or semiconductor microlasers to detect ultrasound by means of monitoring the frequency modulation of the laser output due to the interaction of the ultrasonic disturbance with each individual laser cavity. Each VCSEL array may contain, for example, about ten (10) to about ten thousand (10,000) or more individual microlasers or pixels as may be required or as can be fabricated by semiconductor processing methods.

[0025] Currently, considerable scientific research is being conducted in the characterization and improvement of VCSEL's. A useful description of the state of the art can be found in recent publications, one by Jewell et. al. "Vertical-Cavity Surface-Emitting Lasers: Design, Growth, Fabrication, Characterization", IEEE Journal of Quantum Electronics, 27 (1991) p. 1332 and one by Slusher "Semiconductor Microlasers and Their Applications", Optics & Photonics News, February 1993, p.8.

[0026] VCSEL's can be incorporated in acoustic detectors by a plurality of various arrangements. For example, two possible arrangements of incorporating VCSEL's in an acoustic detector in order to minimize electrical interconnects for the different pixels are shown schematically in figures 2 and 3.

[0027] Figure 2 illustrates one possible arrangement for detector 20 which uses optical fibers to communicate

the output signal from each VCSEL pixel to the signal processing assembly. In this arrangement, the VCSEL array 42 is fabricated onto an acoustic matching layer 44 which is designed to allow maximum acoustic coupling into the detector assembly. An acoustic damping layer 46 is employed after the array 42 for extinguishing the acoustic energy in order to avoid reflections within the detector. Alternatively, an acoustic reflecting layer can be employed in place of the damping layer 46, depending on the sensitivity and bandwidth requirements of the specific application.

[0028] The frequency modulation of the laser output caused by the acoustic disturbance is then converted into amplitude modulation in a Fabry-Perot cavity array 48 or a single Fabry-Perot cavity attached to the damping layer 46. This cavity array 48 could also employ a spatial light modulator array or some other tuning element array which would allow feedback to correct for any laser fluctuations at frequencies lower than the acoustic frequency. Finally, an array of fiber optic couplers 50 would couple the amplitude modulated signal to the signal processing assembly 30.

[0029] Figure 3 illustrates a detector 20 arrangement which eliminates the need for the fiber optic bundle 50 to carry the signal information to the signal processing assembly 30. This arrangement is similar to that illustrated in Figure 2 except that the optical information is converted to electrical information at the detector head using a charge-coupled-device (CCD) array 52. By using a CCD or a combination of a few CCD's to image all the pixels, all the light-amplitude modulation information can be communicated back to the signal processing assembly 30 using only 1 or, at most, a few signal lines 54. In order to accomplish this, the CCD frame rate be fast compared to the acoustic frequency. Current state of the art CCD arrays have frame rates of greater than 100 KHz. Such CCD arrays should provide for successful analysis of acoustic frequencies up to about 50 KHz.

[0030] If the signal transmission rate from the CCD is high enough, it might be necessary to replace the electrical signal lines 54 with an optical fiber using techniques known in the art of fiber optic communications in order to send the information to the signal processing assembly 30.

[0031] Figure 4 illustrates one possible arrangement for an ultrasonic microscope. A sample 56 to be imaged is in acoustic contact with the VCSEL array 42 by an acoustic impedance matching layer 44. The VCSEL array 42 generates an array of optical beams 60 whose optical frequencies are modulated by the incident ultrasonic field. An acoustic damping layer 46 is employed after the array 42 for extinguishing the acoustic energy in order to avoid reflections within the detector. Alternatively, an acoustic reflecting layer can be employed in place of the damping layer 46, depending on the sensitivity and bandwidth requirements of the specific application. The beams 60 are propagated to the previously described Fabry-Perot cavity array 48 and CCD array

52. The high frequency capability of a VCSEL allows high ultrasonic frequencies to be used resulting in superior spatial imaging resolution.

[0032] Detectors, in accordance with the present invention, are advantageously used in acoustic energy imaging systems such as ultrasound systems used for medical imaging or for non-destructive evaluation of materials, for ultrasonic microscopy and for undersea acoustic sensing.

[0033] The two most important distinguishing points for the purposes of the present invention are: (1) that an array of VCSEL's can be fabricated with a surface area for each laser or pixel on the order of about 10 microns squared and a cavity length on the order of about a few microns and (2) the lasers can be electrically pumped. The first distinguishing point implies that VCSEL acoustic detection allows extremely small pixels for two dimensional sensing arrays. Additionally, it can be shown that, for certain acoustic impedance matching layer combinations, the acoustic frequency detection bandwidth increases as the detecting laser cavity length decreases when the detection interaction involves a change in laser cavity length and the condition that the cavity length be much smaller than the acoustic wavelength holds. Thus, the small VCSEL cavity length leads to a high acoustic frequency detection bandwidth. The second point implies that the whole array can be powered by only two electrical lines.

[0034] While the systems and apparatus contained herein constitute preferred embodiments of the invention, it is to be understood that the invention is not limited to these precise systems and apparatus, and that changes may be made therein without departing from the scope of the invention which is defined in the appended claims.

#### Claims

1. A detector for detecting acoustic energy propagating through a medium, the detector comprising:
  - a detector housing, and
  - an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively positioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field.
2. The detector of claim 1 wherein the resulting laser output is frequency modulated by the acoustic field.
3. The detector of claim 1 further comprising:
  - an acoustic matching layer, operatively connected to the electrically pumped vertical cavity surface emitting laser (VCSEL) array, for allowing maximum acoustic coupling into the detector.
4. The detector of claim 1 further comprising:
  - an acoustic damping layer operatively positioned after the electrically pumped vertical cavity surface emitting laser (VCSEL) array for extinguishing the acoustic energy in order to avoid reflections within the detector.
5. The detector of claim 1 further comprising:
  - an acoustic reflecting layer operatively positioned after the electrically pumped vertical cavity surface emitting laser (VCSEL) array.
6. An ultrasonic microscope comprising:
  - an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively positioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field;
  - an acoustic matching layer operatively positioned between the electrically pumped vertical cavity surface emitting laser (VCSEL) array and a sample to be imaged;
  - a transparent acoustic damping layer operatively connected to the VCSEL array, the VCSEL array generating an array of optical beams whose optical frequencies are modulated by the incident ultrasonic field, the beams being propagated through free space; and
  - a Fabry-Perot cavity, operatively positioned relative to the damping layer but separated therefrom, for converting the frequency modulation of the laser output caused by the acoustic field into amplitude modulation.
7. The ultrasonic microscope of claim 6 further comprising:
  - a charge-coupled-device (CCD) array, operatively connected to the Fabry-Perot cavity.
8. An ultrasound system for analyzing a subject, comprising:
  - a detector, and
  - a signal processing assembly operatively connected to the detector, the optical detector comprising:
    - a detector housing, and
    - an electrically pumped vertical cavity surface emitting laser (VCSEL) array operatively positioned in the detector housing, each pixel of the array being a laser having a cavity length, the cavity length being modulated by an acoustic field.
9. The system of claim 8 wherein the resulting laser

output is frequency modulated by the acoustic field.

10. The system of claim 8 further comprising:

an acoustic matching layer, operatively connected to the electrically pumped vertical cavity surface emitting laser (VCSEL) array, for allowing maximum acoustic coupling into the detector.

**Patentansprüche**

1. Detektor zum Detektieren von akustischer Energie, die sich durch ein Medium ausbreitet, wobei der Detektor enthält:

ein Detektorgehäuse und  
ein elektrisch gepumptes flächenemittierendes Vertikalkammer-Laserarray (VCSEL), das operativ in dem Detektorgehäuse angeordnet ist, wobei jedes Pixel von dem Array ein Laser ist, der eine Kammerlänge hat, wobei die Kammerlänge durch ein akustisches Feld moduliert wird.

2. Detektor nach Anspruch 1, wobei die entstehende Laserausgangsgröße durch das akustische Feld frequenzmoduliert ist.

3. Detektor nach Anspruch 1, ferner enthaltend:  
eine akustische Anpassungsschicht, die operativ mit dem elektrisch gepumpten flächenemittierenden Vertikalkammer-Laserarray (VCSEL) verbunden ist, um eine maximale akustische Kopplung in den Detektor zu gestatten.

4. Detektor nach Anspruch 1, enthaltend:  
eine akustische Dämpfungsschicht, die operativ hinter dem elektrisch gepumpten flächenemittierenden Vertikalkammer-Laserarray (VCSEL) positioniert ist zum Löschen der akustischen Energie, um Reflexionen in dem Detektor zu vermeiden.

5. Detektor nach Anspruch 1, ferner enthaltend:  
eine akustische Reflexionsschicht, die operativ hinter dem elektrisch gepumpten flächenemittierenden Vertikalkammer-Laserarray (VCSEL) angeordnet ist.

6. Ultraschall-Mikroskop enthaltend:

ein elektrisch gepumptes flächenemittierendes Vertikalkammer-Laserarray (VCSEL), das operativ in dem Detektorgehäuse angeordnet ist, wobei jedes Pixel von dem Array ein Laser ist, der eine Kammerlänge hat, wobei die Kammerlänge durch ein akustisches Feld moduliert wird,  
eine akustische Anpassungsschicht, die opera-

tiv zwischen dem elektrisch gepumpten flächenemittierenden Vertikalkammer-Laserarray (VCSEL) und einer abzubildenden Probe angeordnet ist,

eine transparente akustische Dämpfungsschicht, die operativ mit dem VCSEL Array verbunden ist, wobei das VCSEL Array ein Array von optischen Bündeln generiert, deren optische Frequenzen durch das auftreffende Ultraschallfeld moduliert werden, wobei sich die Bündel durch den freien Raum ausbreiten, und eine Fabry-Perot-Kammer, die operativ relativ zur Dämpfungsschicht angeordnet ist, aber davon getrennt ist, zum Umwandeln der Frequenzmodulation der Laserausgangsgröße, die durch das akustische Feld hervorgerufen ist, in Amplitudenmodulation.

7. Ultraschall-Mikroskop nach Anspruch 6, ferner enthaltend:

ein ladungsgekoppeltes Vorrichtung(CCD)-Array, das operativ mit der Fabry-Perot-Kammer verbunden ist.

8. Ultraschall-System zum Analysieren eines Subjekts, enthaltend:

einen Detektor und  
eine Signalverarbeitungseinrichtung, die operativ mit dem Detektor verbunden ist, wobei der optische Detektor enthält:  
ein elektrisch gepumptes flächenemittierendes Vertikalkammer-Laserarray (VCSEL), das operativ in dem Detektorgehäuse angeordnet ist, wobei jedes Pixel von dem Array ein Laser ist, der eine Kammerlänge hat, wobei die Kammerlänge durch ein akustisches Feld moduliert wird.

9. System nach Anspruch 8, wobei die entstehende Laserausgangsgröße durch das akustische Feld frequenzmoduliert ist.

10. System nach Anspruch 8, ferner enthaltend:  
eine akustische Anpassungsschicht, die akustisch mit dem elektrisch gepumpten flächenemittierenden Vertikalkammer-Laserarray (VCSEL) verbunden ist, um eine maximale akustische Kopplung in den Detektor zu gestatten.

**Revendications**

1. Détecteur servant à mesurer une énergie acoustique propagée à travers un milieu, le détecteur comprenant:

un boîtier de détecteur, et

- un groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, placé activement dans le boîtier de détecteur, chaque pixel du groupement étant un laser présentant une certaine longueur de cavité, la longueur de cavité étant modulée par un champ acoustique. 5
2. Détecteur selon la revendication 1, dans lequel l'émission laser obtenue est modulée en fréquence par le champ acoustique. 10
3. Détecteur selon la revendication 1, comprenant en outre:  
une couche d'adaptation acoustique, connectée activement au groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, pour obtenir un couplage acoustique maximum dans le détecteur. 15
4. Détecteur selon la revendication 1, comprenant en outre:  
une couche d'amortissement acoustique, placée activement après le groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, pour faire disparaître l'énergie acoustique afin d'éviter des réflexions à l'intérieur du détecteur. 20
5. Détecteur selon la revendication 1, comprenant en outre:  
une couche de réflexion acoustique, placée activement après le groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique. 25
6. Microscope à ultrasons, comprenant:  
un groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, placé activement dans le boîtier de détecteur, chaque pixel du groupement étant un laser présentant une certaine longueur de cavité, la longueur de cavité étant modulée par un champ acoustique; 30  
une couche d'adaptation acoustique, placée activement entre le groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique et un échantillon à imager; 35  
une couche d'amortissement acoustique transparente, connectée activement au groupement de LESC, le groupement de LESC générant un groupement de faisceaux optiques dont les fréquences optiques sont modulées par le champ ultrasonore incident, les faisceaux étant propagés à travers l'espace libre; et 40  
une cavité de Fabry-Perot, placée activement 45
7. Microscope à ultrasons selon la revendication 6, comprenant en outre:  
un groupement de dispositifs à couplage de charges (CCD), connecté activement à la cavité de Fabry-Perot. 50
8. Système ultrasonore pour analyser un sujet, comprenant:  
un détecteur, et  
un ensemble de traitement du signal connecté activement au détecteur, le détecteur optique comprenant:  
un boîtier de détecteur, et  
un groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, placé activement dans le boîtier de détecteur, chaque pixel du groupement étant un laser présentant une certaine longueur de cavité, la longueur de cavité étant modulée par un champ acoustique. 55
9. Système selon la revendication 8, dans lequel le rayonnement laser obtenu est modulé en fréquence par le champ acoustique.
10. Système selon la revendication 8, comprenant en outre:  
une couche d'adaptation acoustique, connectée activement au groupement de lasers émettant par la surface d'une cavité verticale (LESCV) à pompage électrique, pour obtenir un couplage acoustique maximum dans le détecteur.

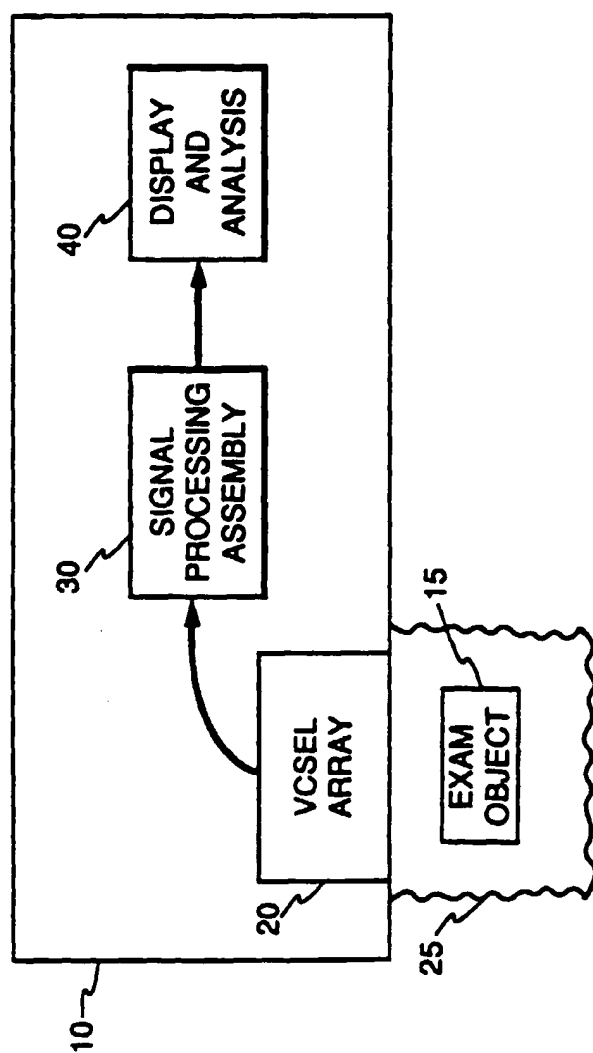
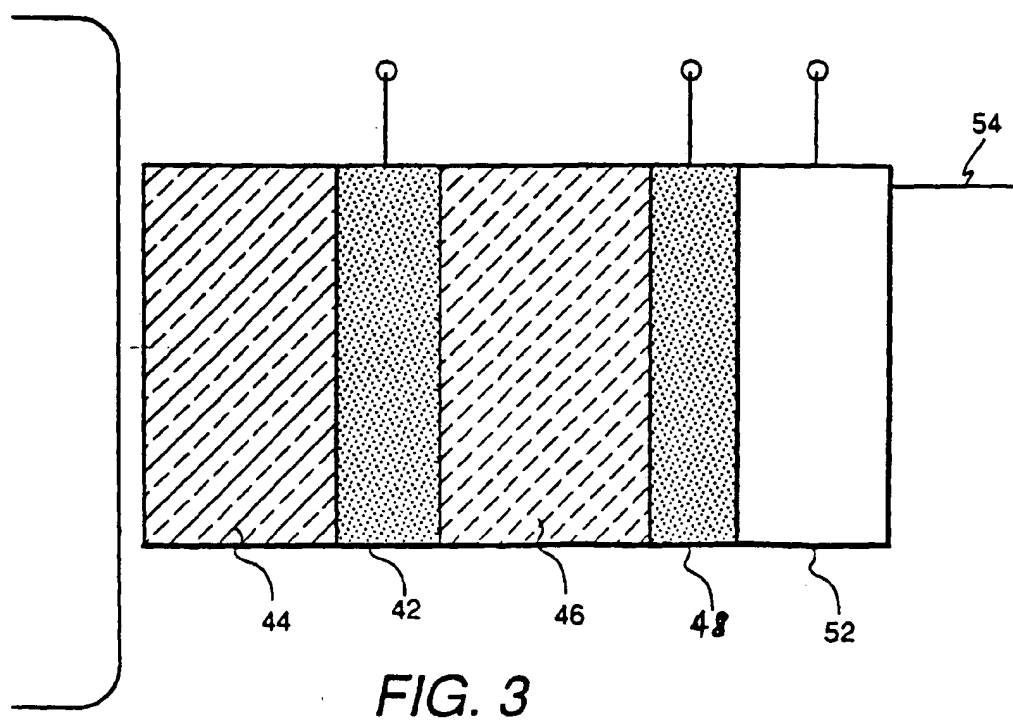
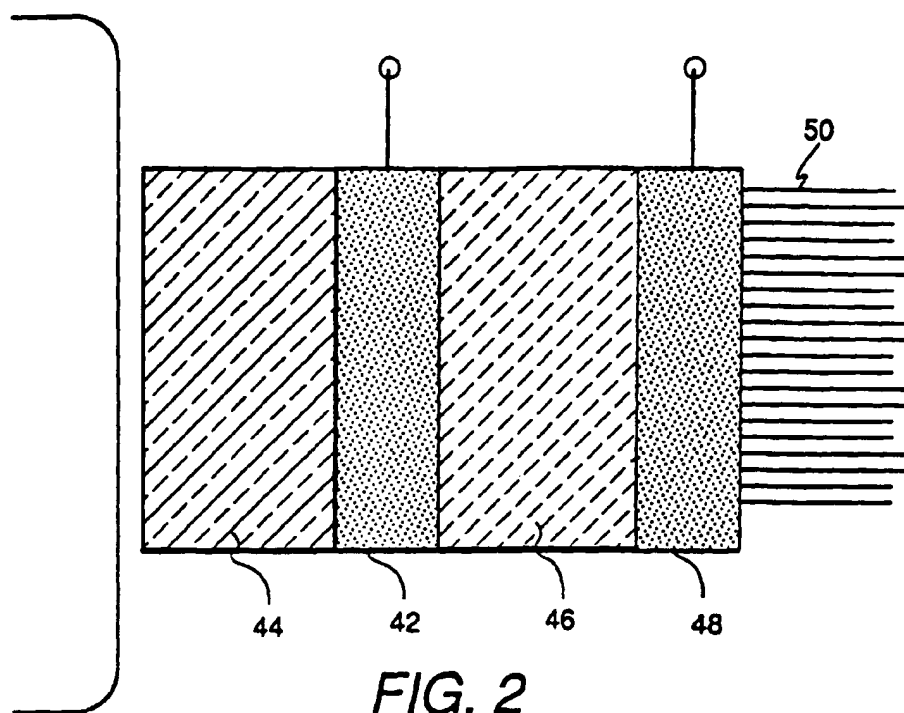


FIG. 1





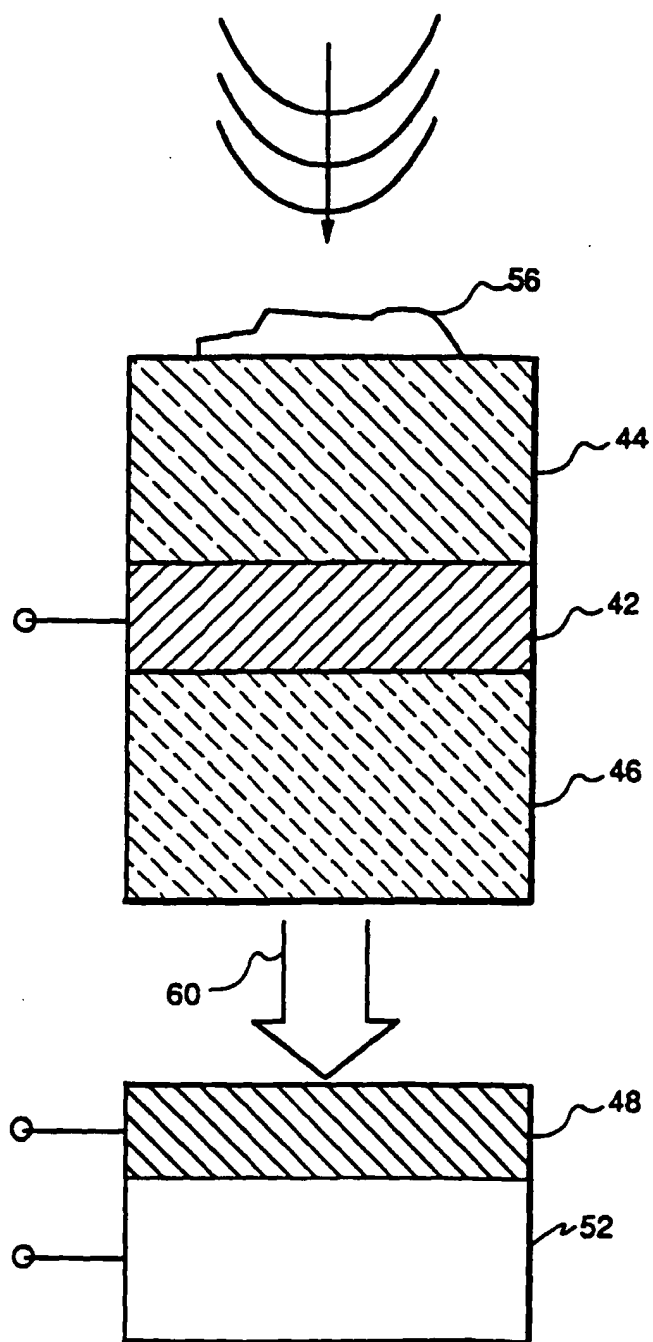


FIG. 4